



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Daxing Ren) Group Art Unit: 1765
Application No.: 10/706,938) Examiner: DuyVu N. Deo
Filed: November 14, 2003) Confirmation No.: 7427
For: SILICON CARBIDE COMPONENTS OF)
SEMICONDUCTOR SUBSTRATE)
PROCESSING APPARATUSES)
TREATED TO REMOVE FREE-CARBON)

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the restriction requirement set forth in the Official Action dated October 20, 2005, Applicant hereby elects, with traverse, the invention covered by Group II, Claims 11-14.

Early and favorable consideration on the merits is respectfully requested.

Respectfully submitted,

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